Title: METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE Inventor: Kei KANEMOTO
Atty. Ref.: 9319S-000544

FIG.1

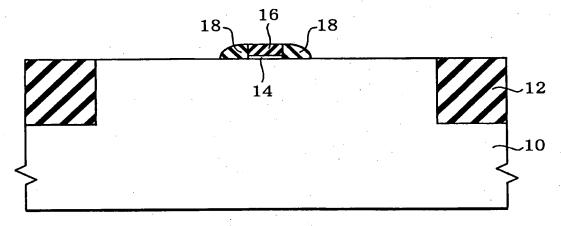


FIG.2

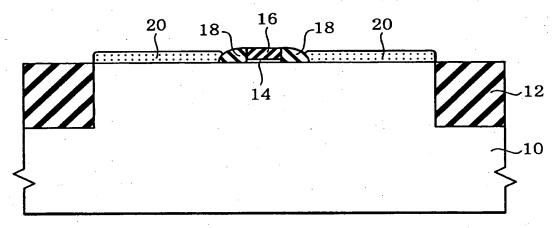
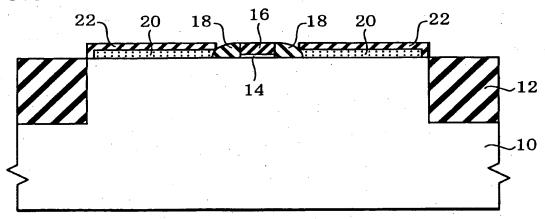


FIG.3



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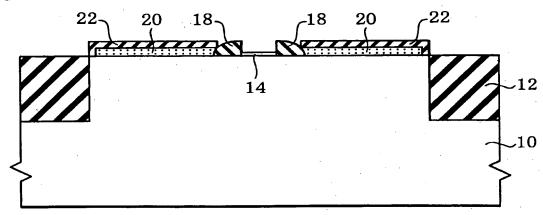


FIG.5

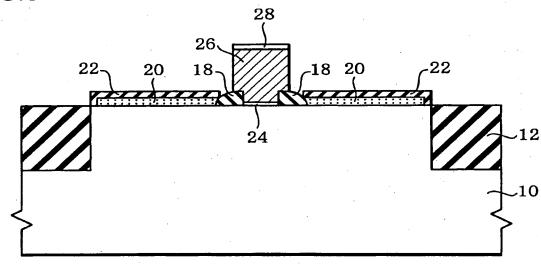
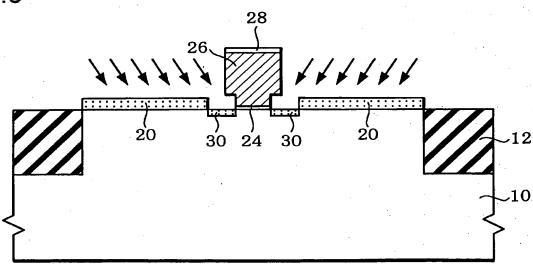


FIG.6



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Atty. Ref.: 9319S-000544

FIG.7

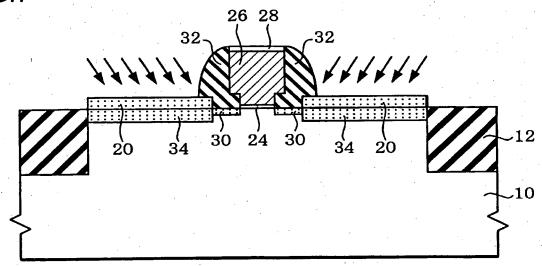
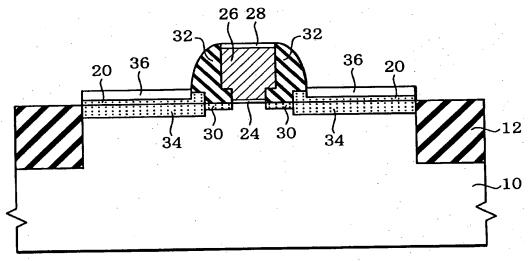


FIG.8



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FIG.9

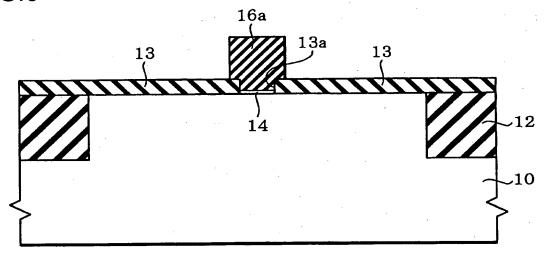
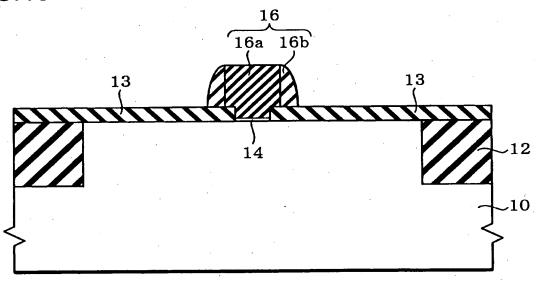


FIG.10



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FIG.11

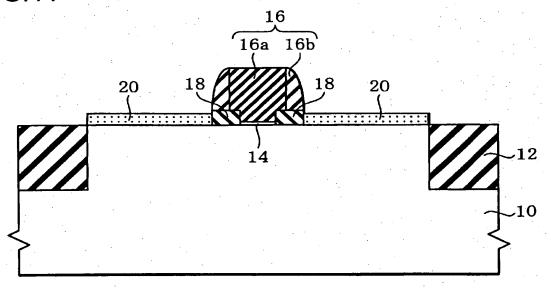


FIG.12

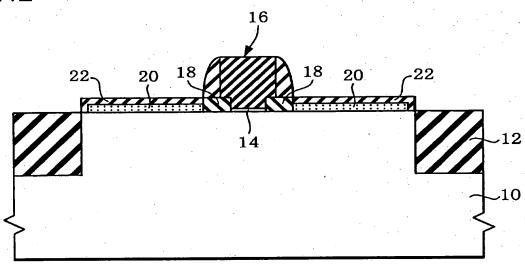


FIG.13

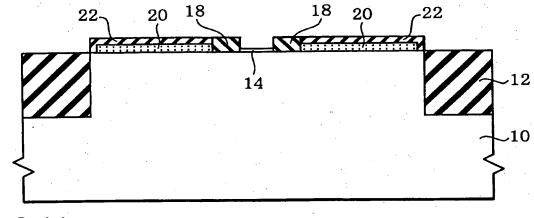


FIG.14

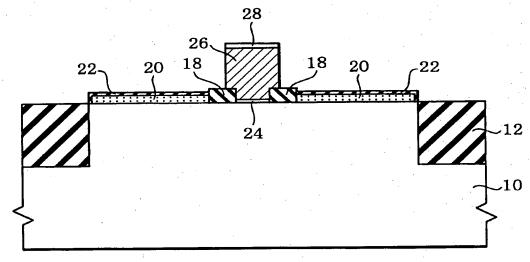
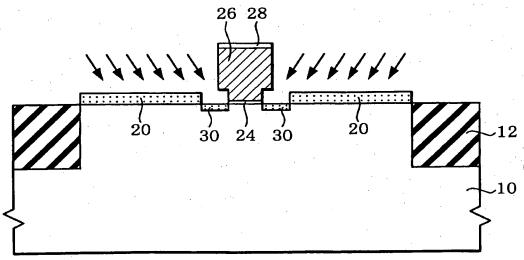


FIG.15



Title: METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE Inventor: Kei KANEMOTO

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FIG.16

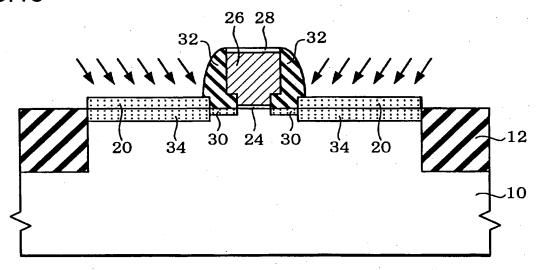


FIG.17

